

Polyoxometalate-based Colloidal Crystal Thin Film

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An inverse opal structure three-dimensional array film of polyoxometalates (POMs) was constructed by using polystyrene (PS) colloidal crystals as templates. The thin film has exact inverse opal structure and the POMs remained Keggin structure.

To fabricate films composed of functional molecules is crucial to both fundamental research and application. In recent years, POMs as inorganic functional clusters attract increasing attention due to their stability against oxidation and variety of physicochemical properties,¹ so precise construction of a thin film or three-dimensional (3D) array of POMs is desired for realizing POMs-based molecular devices. For POMs, the ordered property and porous media of resulting arrays are highly accessible, potentially exploitable for applications, such as catalysts,² magnetism,³ and photochromism.⁴

Traditionally, thin films of POMs are typically made by dip coating,⁵ the Langmuir–Blodgett technique,⁶ electrodeposition,⁷ or layer-by-layer (LBL) self-assembly technique.⁸ However, there are only few reports about the preparation of 3D-ordered structure based on POMs, such as self-assemble method⁹ or an ordered array of surfactant.¹⁰

Colloidal crystal template is another promising way for fabrication of thin film. This method offers a simple and inexpensive route to form 3D-ordered structure film. A promising prototype of 3D opal colloidal crystal is obtained by self-organization of monodispersion latex or silica spheres. And the inverse opal colloidal crystal replica can be produced by infiltration of nanometer-sized precursor,¹¹ and further remove the colloidal crystal template by chemical etching or calcinations, so the 3D-ordered structure film is built up. Many inverse opal structure colloidal crystals have been prepared such as metal oxide¹² (TiO₂, Fe₂O₃, ZnO, Mn₂O₃, MgO, NiO, Co₂O₃, and NiO), alloy,¹³ and semiconductor,^{12,14,15} salt.¹⁵ Usually, the precursor may be nanoparticles,¹⁶ sol–gel,^{12,14,15} or solution.¹⁷ Owing to the small diameter and the well solubility of POMs, it is difficult to fabricate POMs array thin film directly using POMs salt, so the sol–gel route seems to be the most appropriate way.

In this paper, we successfully fabricated POMs-based thin film using sol–gel process and polystyrene (PS) colloidal crystal as template. This offers a promising way to synthesize this new well-ordered POMs-based thin film colloidal crystal material and brings about the investigation of new properties and applications.

The 660-nm diameter polystyrene monodisperse spheres were synthesized according to the method of Stein,¹² and the PS colloidal crystal template was prepared by a convective

self-assembly method¹⁸ on the substrates (glass or silicon wafers). The POMs sol was prepared as follows: a 5-mL ethanol solution of 2-mL tetraethyl orthosilicate (TEOS) was dropped into a 10-mL aqueous solution of 2-g H₃PW₁₂O₄₀ (PW₁₂) with gentle stirring for about 60 min at room temperature to form PW₁₂/SiO₂ sol.

After forming PW₁₂/SiO₂ sol, the substrate with the PS colloidal crystal template was soaked in the PW₁₂/SiO₂ sol for about 2 h. During this process, PW₁₂/SiO₂ sol infiltrated into the PS colloidal crystal template, the voids of the PS template were filled with liquid sol by capillary force. The substrate was taken off from the PW₁₂/SiO₂ sol, stood at room temperature until dry. Most of the solvent vaporated and the PW₁₂/SiO₂ gel formed, which resulted in forming an intermediate composite structure of PW₁₂/SiO₂/PS. The PW₁₂/SiO₂ inverse opal structure colloidal crystal film was prepared by extracting the PS template using a solution of tetrahydrofuran (THF)/acetone (1:1) for about 24 h.

The concentration of H₃PW₁₂O₄₀ in film characterized by ICP-AES was W, 36.7%, P, 0.53%, respectively. The molar ratio of P:W is 1:12, indicating that the PW₁₂ in the PW₁₂/SiO₂ film remained Keggin structure. The loading of PW₁₂ on the film was about 47.9%.

The thin PW₁₂/SiO₂ film assembled on the silicon substrate was characterized by IR (4000–400 cm^{−1}, KBr) and UV–vis (756 CRT). In the spectrum of PW₁₂/SiO₂ film, four characteristic peaks at 1080, 987, 894, and 793 cm^{−1} can be attributed to ν as (P–Oa), ν as (W–Od), ν as (W–Ob–W), ν as (W–Oc–W), respectively. Compared to the IR spectra of its parent PW₁₂ (1080, 983, 890–850, and 800–760 cm^{−1}), the shifts of W–Od and W–Ob–W contribute to interaction between PW₁₂ and SiO₂, indicating that the interaction of POMs and SiO₂ is chemical force not simple physical absorption. In the UV–vis spectrum (Figure 1), the characteristic peaks of PW₁₂/SiO₂ films is located at 200 and 266 nm. The first peak is assigned to the Od → W charge-transfer and the second is attributed as the Ob/Oc → W charge-transfer band. So the UV–vis spectra indicates the

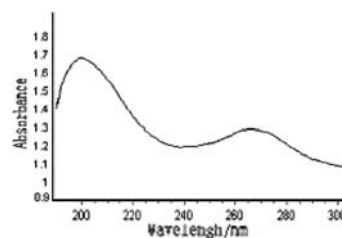


Figure 1. UV–vis spectra of PW₁₂/SiO₂ thin film.

existence of PW_{12} in the film.

In order to confirm the existence of POMs in the $\text{PW}_{12}/\text{SiO}_2$ thin film, the ^{31}P MAS NMR spectra (Varian Unity-400 NMR) was measured. The ^{31}P NMR spectra show two peaks present at -14.3 and -15.1 ppm, respectively, different from that of the pure PW_{12} having one peak at -15.1 ppm with a small line width, which is just the same as literature reported.¹⁹ Therefore, it is confirmed that a strong chemical interaction, not simple physical adsorption, exists between the POM and the silica.²⁰ As the OH groups of silanol are protonated in the acidic medium of PW_{12} , it is supposed that one proton of PW_{12} will react with the OH of silanol and form a SiOH^{2+} group which should act as a counterion for the polyanion. Thus, the reaction is an acid–base reaction between the silanol group (acting as the base) and the polyanion (acting as a Brønsted acid). This interaction results the distinction of ^{31}P NMR spectra between $\text{PW}_{12}/\text{SiO}_2$ and pure PW_{12} . So the silica-supported PW_{12} can be regarded as a Brønsted acid, which has developed both in theory and application. Most of them acted as heterogeneous catalyst to catalyze organic reaction,²¹ decompose organic pollutants.²²

The X-ray photoelectron spectra (XPS) (Escalab-MK II, $\text{AlK}\alpha$ (1200 eV)) was used to examine the component of $\text{PW}_{12}/\text{SiO}_2$ thin film assembled on the glass substrate. The XPS spectra exhibited peaks assignable to O 1s (binding energy (BE) = 532.2 eV), Si 2p (BE = 103.5), P 2p (BE = 135.3), W 4f_{5/2} (BE = 39.05), and W 4f_{7/2} (BE = 36.9). According to the XPS measurement, the presence of O, Si, P, and W atoms in the film was confirmed, and the expected molar ratio of 1:12 for P to W is also approximately established.

The scanning electron microscopy (SEM) (Hitachi H-800, 200 kV) image was measured to confirm the structure of the sample. Figure 2 shows the SEM images of PS colloidal crystal template and PW_{12} -based 3D thin film. It can be seen that the porous structure of film (Figure 2b) is the exact inverse replicas of the opal colloidal crystals (Figure 2a). The POMs/ SiO_2 film (Figure 2b) shows inverse opal structure and the oriented pore framework is observed clearly. A regularly ordered hexagonal arrangement can be observed and the second layer can also be clearly seen.

Small angle X-ray diffraction (SARD) (Rigaku D/max 2500, $\text{CuK}\alpha$, $\lambda = 1.5406$ nm) was measured to investigate the layer structure of the film. Figure 3 showed the SARD pattern of the thin film, which exhibited Bragg peaks similar to Fan reported in the literature.²³ From the SARD pattern, the POM-based film showed well-defined layered structure with regular periodicity. On the basis of the diffraction patterns, the layer distance (d spacing) of thin film calculated using Bragg's equation

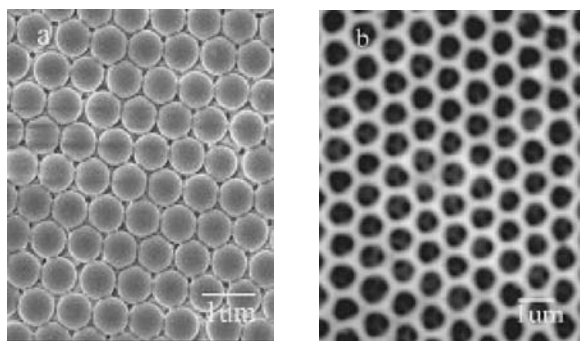


Figure 2. SEM of (a) PS template (b) $\text{PW}_{12}/\text{SiO}_2$ thin film.

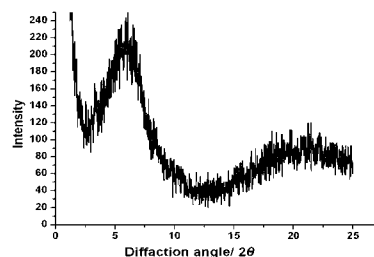


Figure 3. SARD of the $\text{PW}_{12}/\text{SiO}_2$ thin film.

($n\lambda = 2d \sin \theta$) was about 3.29 nm.

We obtained the 3D-ordered $\text{PW}_{12}/\text{SiO}_2$ thin film by PW_{12} sol infiltrating into the PS colloidal crystal template. The inverse opal structure $\text{PW}_{12}/\text{SiO}_2$ film was successfully fabricated which showed 3D-ordered array structure and the POMs remained Keggin structure. The method we reported is an available way to fabricate POMs 3D-ordered array film. But there are still some interesting works need to be achieved, such as constructing different functional thin films by selecting of POMs molecules with appropriate size, structure, component, and charge for different application.

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